Application/Control No. Applicant(s)/Patent Under Reexamination 10/600,770 WU, SHENSHEN Notice of References Cited Art Unit Examiner Page 1 of 1 **David Buttner** 1712 **U.S. PATENT DOCUMENTS** Document Number Date Classification Name Country Code-Number-Kind Code MM-YYYY US-Α В US-US-С US-D US-Ε US-F US-G US-Н US-1 US-US-K US-L US-M **FOREIGN PATENT DOCUMENTS** Document Number Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Ρ Q R s Ţ **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) Oertel; Polyurethane Handbook, 1993, page 103. U ٧

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYYY format are publication dates. Classifications may be US or foreign.

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